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CMC  
03-23-05  
520.39737X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. OTSUBO EXPEDITED PROCEDURE  
Serial No.: 09/842,000 BOX AF  
Filed: April 26, 2001  
For: PLASMA PROCESSING APPARATUS AND PROCESSING METHOD  
Group: 1763  
Examiner: A. Crowell

Entered with RFE  
4/21/5  
mw  
5/2/5

**AMENDMENT AFTER FINAL ACTION**

Mail Stop: Box AF Amendment (Fee)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 15, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the office action dated November 23, 2004, as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.